

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2818
Koichiro TANAKA et al.)	Examiner: Chuong A. Luu
Serial No. 10/787,120)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 1, 2006. Adulum Mayary
Filed: February 27, 2004)	
For: LASER IRRADIATION METHOD,)	
LASER IRRADIATION APPARATUS,)	
AND METHOD FOR)	
MANUFACTURING)	
SEMICONDUCTOR DEVICE)	

<u>AMENDMENT</u>

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated December 1, 2005, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.